



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 13, 2025	
IGI Report Number	LG706518319
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	MARQUISE BRILLIANT
Measurements	17.54 X 9.06 X 5.62 MM

GRADING RESULTS

Carat Weight	5.06 CARATS
Color Grade	F
Clarity Grade	VS 1

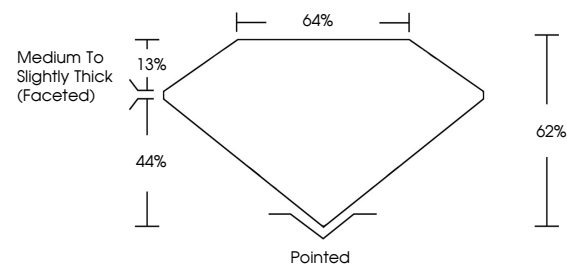
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG706518319

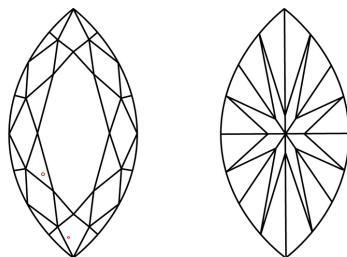
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG706518319
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VWS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³

Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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www.igi.org

	V6 1
	Q2%
	Q4%
	Medium To Slightly Thick (focused)
	Patched
	EXCELLENT
	EXCELLENT
	NONE
	(8) L5705518319

Comments:
 Grown Diamond was created by Chemical Vapor Deposition CVD growth process.
 type IIG